

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Thomas Wendling

Examiner:

Title: Apparatus and Method for
Evenly Flowing Processing
Gas Onto A Semiconductor
Wafer

Group Art:

Serial No.:

Filed:

Assistant Commissioner For Patents
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicant respectfully requests that the following references be considered in the examination of the above-identified application. A copy of each reference is enclosed.

CITED ART

<u>U.S. Patent No.</u>	<u>Inventor(s)</u>	<u>Date Issued</u>
3,854,443	Baerg	Dec. 17, 1974
4,792,378	Rose et al.	Dec. 20, 1988
4,949,669	Ishii et al.	Aug. 21, 1990
5,174,825	White, Jr. Et al.	Dec. 29, 1992
5,455,070	Anderson et al.	Oct. 03, 1995
5,498,909	Hasunuma et al.	Mar. 12, 1996
5,595,602	Harlan	Jan. 21, 1997
5,855,681	Maydan et al.	Jan. 05, 1999
5,901,271	Benzing et al.	May 04, 1999
5,911,834	Fairbain et al.	Jan. 15, 1999
5,954,878	Mandal et al.	Sep. 21, 1999
5,968,593	Sakamoto et al.	Oct. 19, 1999
6,064,800	Sandhu	May 16, 2000
6,068,738	Bjornard et al.	May 30, 2000
6,086,677	Umotoy et al.	July 11, 2000
6,090,211	Kamei et al.	Jan. 18, 2000
6,098,843	Soberanis et al.	Aug. 08, 2000
6,183,563	Choi et al.	Feb. 06, 2000
6,197,121	Gurary et al.	Mar. 06, 2001

jc997 U.S. PTO
09/972544
10/05/01

REMARKS

Under rule 37 C.F.R. 1.98 (a), which is effective as of March 16, 1992, the applicant submits that no specific comments are necessary for the above cited English language publications.

For the Examiner's convenience, the applicant has attached a completed PTO-1449 form hereto.

Respectfully submitted,
Thomas Wendling, Applicant

By: _____
Robert W. Mulcahy
Attorney for Applicants
Registration No. 25,436

Date: September 7, 2001

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Fax. No. (408) 986-3090

ATTY. DOCKET NO.
AMAT-5312

SERIAL NO.

LIST OF CITATIONS BY APPLICANT

(Use several sheets if necessary)

APPLICANT Thomas Wendling

FILING DATE

GROUP

Sheet 1 of 2
U.S. PTO
09/972544

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	6 1 9 7 1 2 1	3/6/01	A.I. Gurary et al.	118	725	6/30/99
AB	6 1 8 3 5 6 3	2/6/01	W. Choi et al.	113	715	5/3/99
AC	6 0 9 8 8 4 3	8/8/00	D. Soberanis et al.	222	53	12/31/98
AD	6 0 9 0 2 1 1	7/18/00	H. Kamel et al.	118	725	3/12/97
AE	6 0 8 6 6 7 7	7/11/00	S.P. Umotoy et al.	118	715	6/16/98
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AH	5 9 6 8 5 9 3	11/19/99	I. Sakamoto et al.	427	243.1	3/20/96
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AK	5 8 5 5 6 8 1	1/5/99	D. Maydan et al.	118	19	11/18/96
AL	5 9 5 4 8 7 8	9/21/99	R.P. Mandal et al.	118	319	6/16/97

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
AL							
AM							
AN							
AO							
AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	
AS	
AT	

EXAMINER

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5 5 9 5 6 0 2	1/21/97	K.S. Harlan	118	715	3/14/95
AB	5 4 9 8 9 0 9	3/12/96	M. Hasunuma et al.	257	754	3/31/92
AC	5 4 5 5 0 7 0	10/3/95	R.N. Anderson et al.	427	248.1	9/16/93
AD	5 1 7 4 8 2 5	12/29/92	D.White, Jr. et al.	118	715	8/23/90
AE	4 9 4 9 6 6 9	8/21/90	K. Ishil et al.	118	733	12/20/88
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AK						

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						YES	NO
AL							
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AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

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